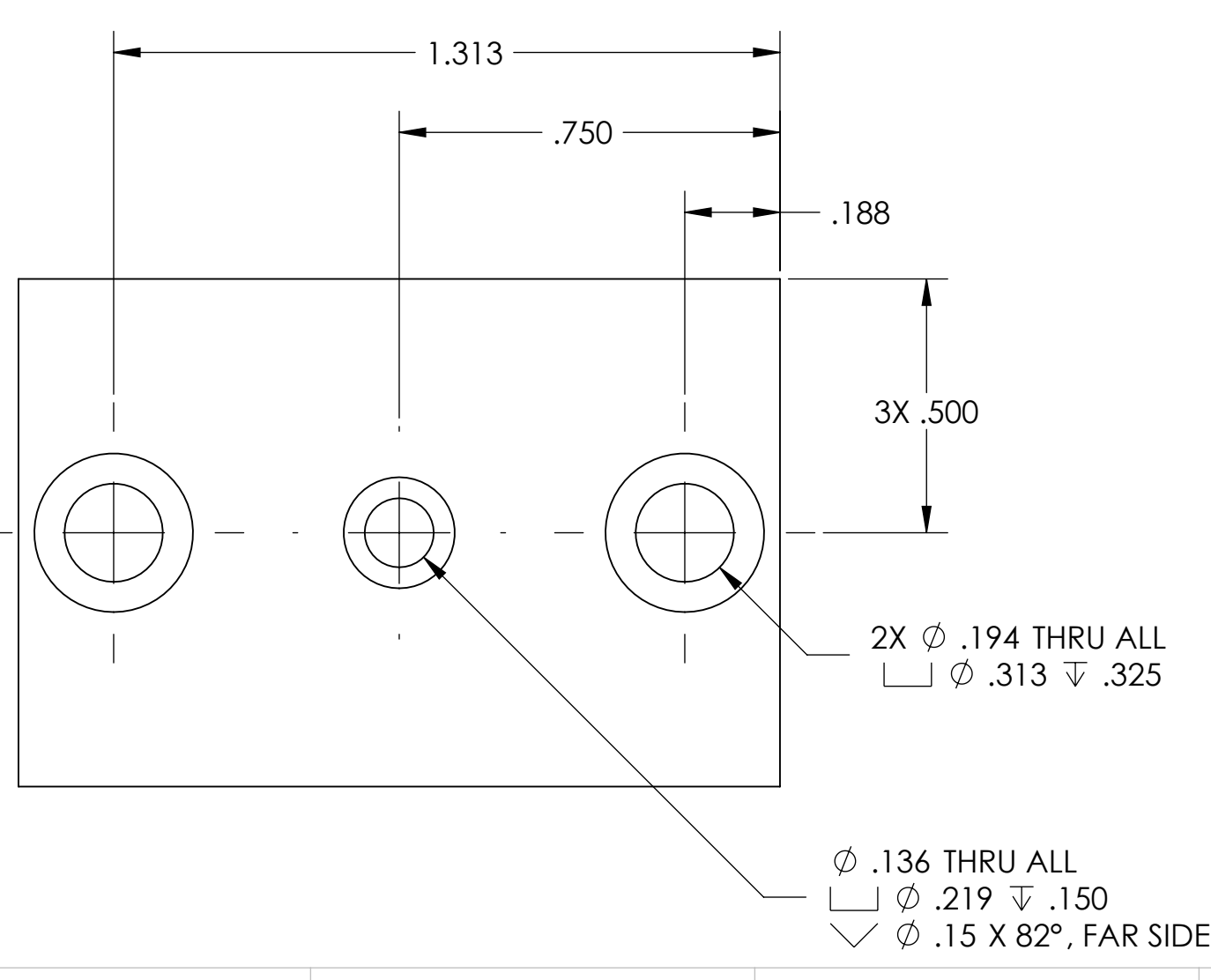
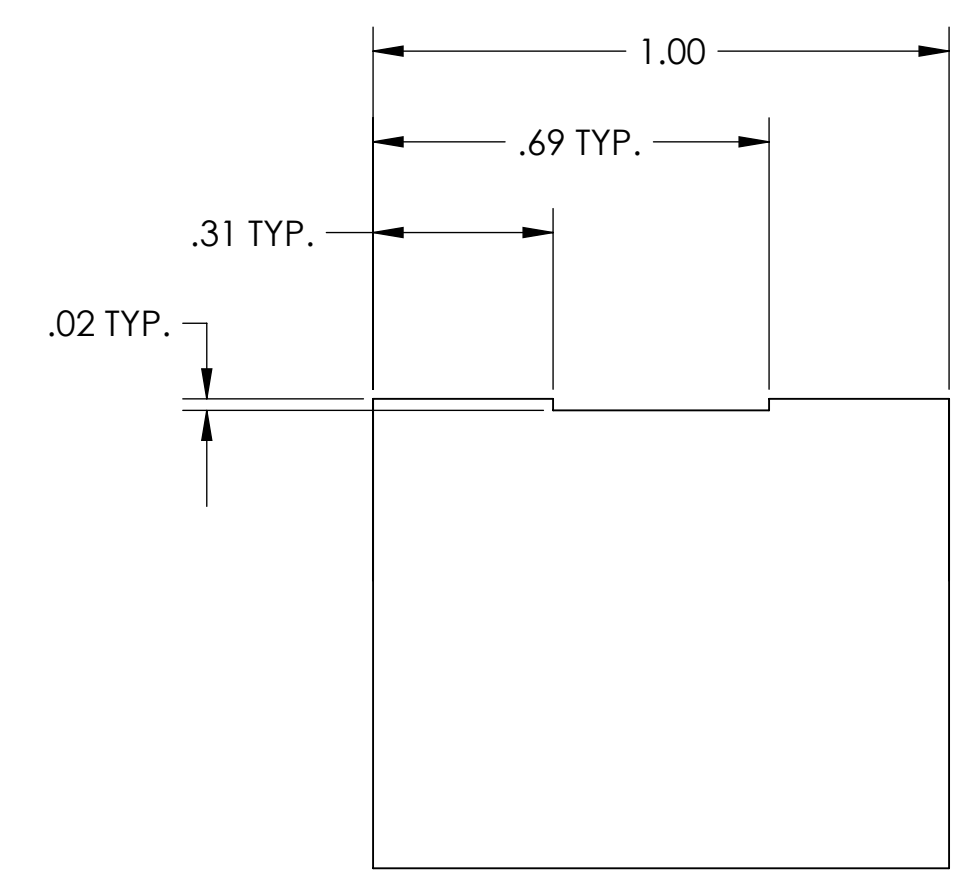
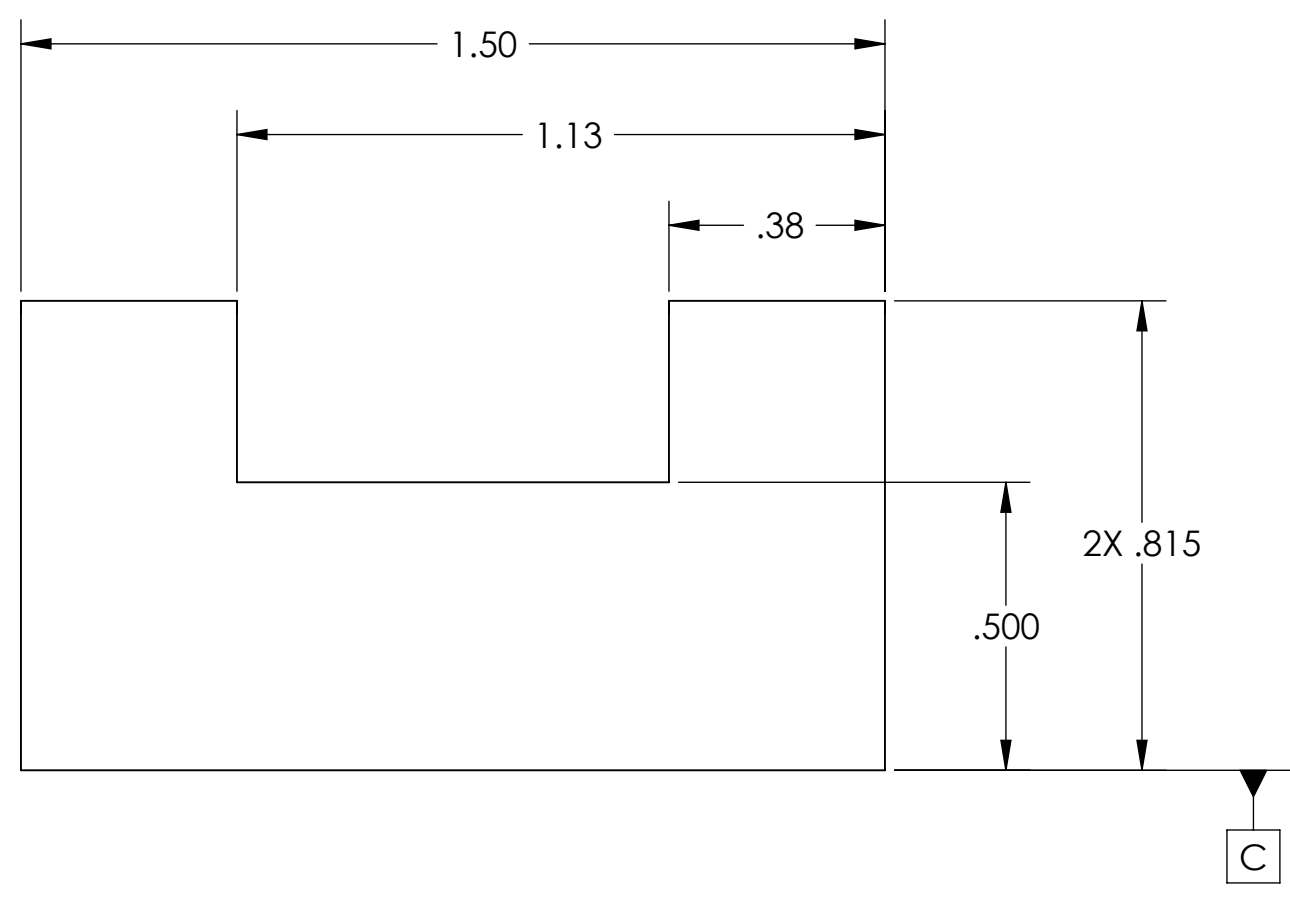
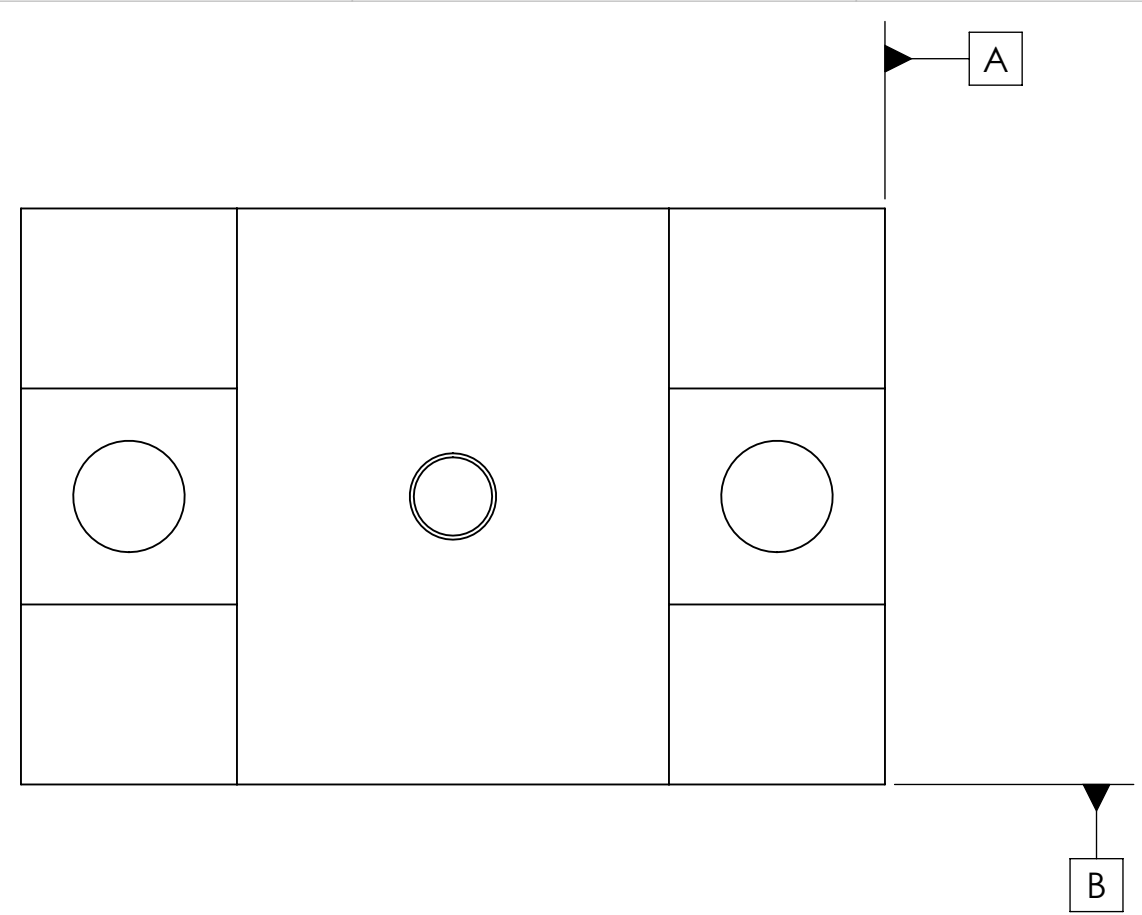
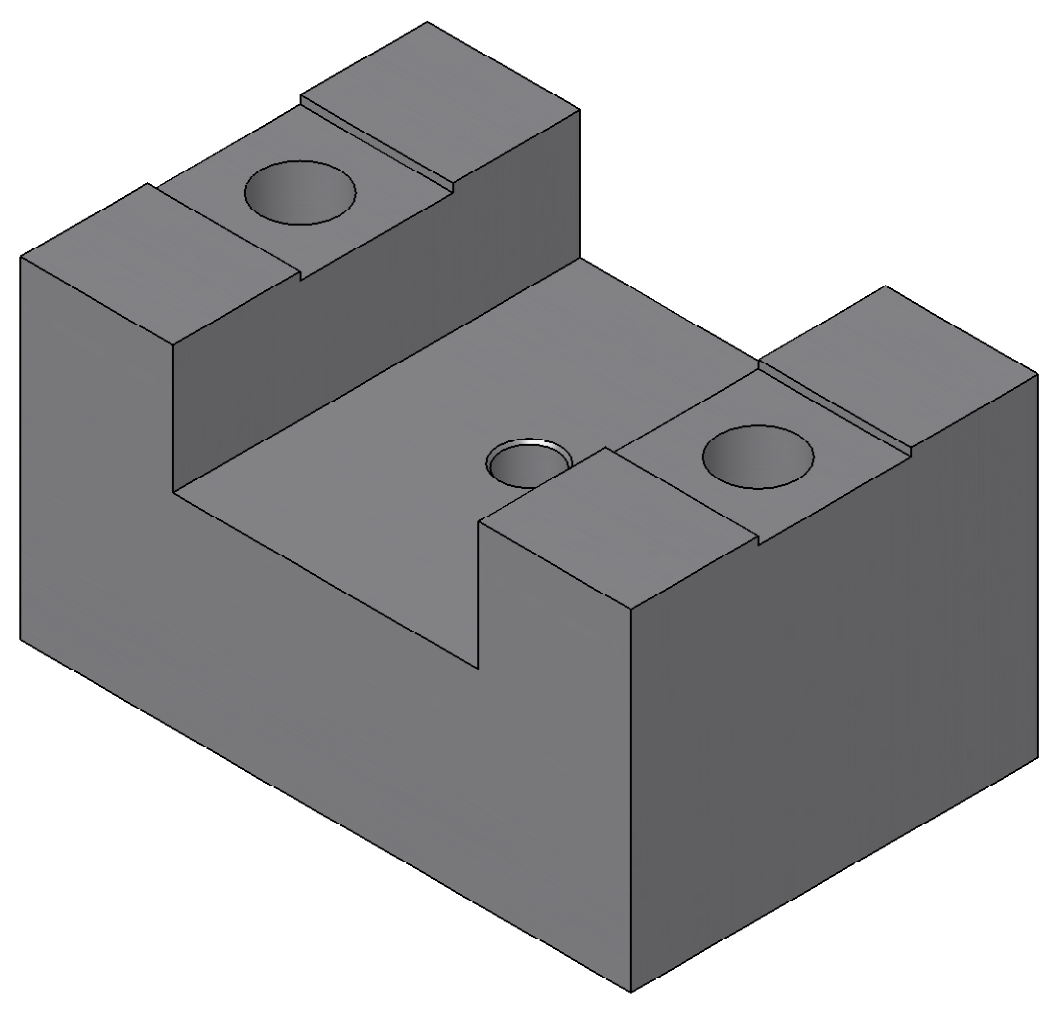


REV	DATE	APPROVAL	DESCRIPTION
00	10/27/2008	A. STEIN	PROTOTYPE RELEASE.



NOTES: (UNLESS OTHERWISE SPECIFIED)

- DO NOT SCALE FROM DRAWING.
- REMOVE ALL SHARP EDGES. LEAVE .005 X 45° MIN CHAMFER, OR .005 MIN RADIUS.
- ALL MACHINING FLUIDS MUST BE WATER SOLUBLE AND FREE OF SULFUR, CHLORINE AND SILICONE. E.G., MILACRON CIMTECH 410.
- CLEAN THOROUGHLY TO REMOVE ALL OIL, DIRT, AND CHIPS.

DIMENSIONS ARE IN INCHES
TOLERANCES:
.XX ± 0.015
.XXX ± 0.005
ANGULAR ± 0.5°

MATERIAL 6061-T6

FINISH NONE

DRAWN A. STEIN 10/27/2008

CHECKED

APPROVED

CALIFORNIA INSTITUTE OF TECHNOLOGY
MASSACHUSETTS INSTITUTE OF TECHNOLOGY
IGR, GLASGOW UNIVERSITY GEO 600 GROUP

SYSTEM ADVANCED LIGO

SUB-SYSTEM SEI

NEXT ASSY D080673

PART NAME KAMAN SENSOR MOUNT 2

SIZE C **DWG. NO.** D080671 **REV.** 00

SCALE: 3:1 **PROJECTION:** **SHEET 1 OF 1**